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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Gupta, Subhadra

SERIAL NO.: 10/667,202

FILED: September 19, 2003

TITLE: LINEAR SWEEPING MAGNETRON SPUTTERING
CATHODE AND SCANNING IN-LINE SYSTEM FOR
ARC-FREE REACTIVE DEPOSITION AND HIGH
TARGET UTILIZATION

Hon. Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE REGARDING DRAWINGS


In response to the Notice Regarding Drawings, enclosed are fifteen (15) sheets of formal drawings.

Respectfully submitted,

Thomas A. O'Rourke
Reg. No.: 27,665
Bodner & O'Rourke, LLP
425 Broadhollow Road, Suite 108
Melville, NY 11747
(631) 249-7500



I hereby certify that the foregoing document and fees were mailed by first class mail, postage prepaid, in an envelope addressed to the Hon. Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, this 13th day of June, 2006.


Thomas A. O'Rourke